

自動化・微環境・機電整合

AUTOMATION SYSTEM INTEGRATION PARTICLE CONTROL



Automated wafer storage loader · ISO 1 cleanroom

FEATURE

- Efficient air duct design ensures clean air to be directed stably to required location.
- Equipped with servo control system for precise control and movements.
- Intuitive interface allows user to keep track of status.
- Fan speed can be automatically detected and adjusted to achieve energy efficiency (opt)
- Equipped with self-developed ISO 1 air filtration units (fan filter unit).

BENEFIT

- Each functional module operates independently, allowing different combinations upon request.
- Customized configuration such as air flow/direction, temperature and humidity, can be tailored to requirements.
- Can be applied to other process and equipment such as oven systems, drying equipment and AOI etc.